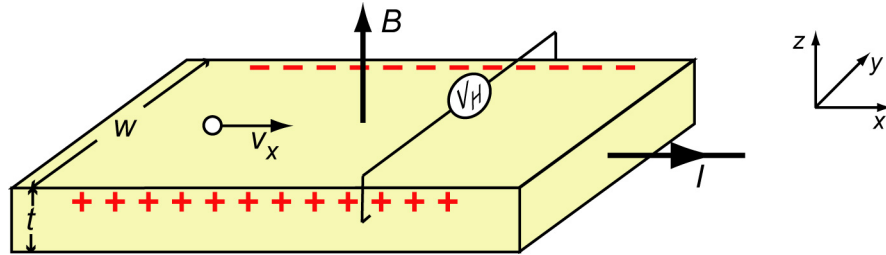


## Hall Effect

The Hall Effect was discovered by E. H. Hall in 1879 when he investigated the nature of the force acting on a conductor carrying a current in a magnetic field. He found that the magnetic field exerts a transverse force (Lorentz force) on the moving charge carriers and the force tends to push the carriers to one side of the conductor, as illustrated in the figure below. A buildup of charges at the sides of the conductors will create an electric field that balances the Lorentz force, thereby producing a measurable voltage in the transverse direction.



Assume a p-type semiconductor with carrier concentration  $p$ , a current  $I$  flowing in the  $x$ -direction, and a magnetic field  $B$  applied in the  $z$ -direction. The electric field occurring in the  $y$ -direction produces the Hall voltage  $V_H$  given by

$$V_H = \int_0^w \varepsilon_y dy = \int_0^w \frac{B I}{q w t p} dy = \frac{B I}{q t p}$$

The Hall coefficient  $R_H$  (given in units of  $\text{m}^3/\text{C}$ ) is defined as

$$R_H = \frac{t V_H}{B I}$$

giving

$$p_H = \frac{1}{q R_H}$$

Similarly, the carrier concentration of n-type semiconductor can be determined by

$$n_H = -\frac{1}{q R_H}.$$

The Hall mobility  $\mu_H$  is defined by

$$\mu_H = \frac{|R_H|}{\rho} = |R_H| \sigma.$$

## Hall Effect measurement

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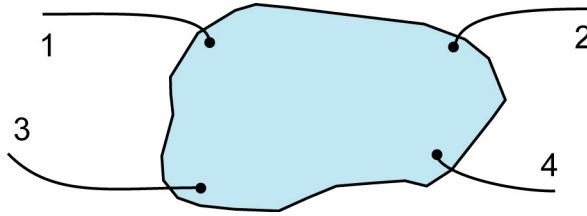
For a flat sample of irregular shape, the van-der-Pauw model can be applied to determine the resistivity, carrier concentration, and mobility. The following conditions need to be met.

- (1) the contacts are at the circumference of the sample
- (2) the contact are sufficiently small
- (3) the sample is uniformly thick

For the sample illustrated in the figure below, the resistivity is given by

$$\rho = \frac{\pi t}{\ln 2} \frac{R_{12,34} + R_{23,41}}{2} F$$

where  $R_{12,34} = V_{34} / I$ . The current  $I$  goes from Contact 1 to Contact 2.  $V_{34} = V_4 - V_3$  is the voltage between Contact 3 and 4. For symmetric samples, like squares or circles,  $F = 1$  ( $F$  indicates the symmetry of the sample and contacts).



The Hall coefficient is given by

$$R_H = \frac{t \Delta V_{34}}{2 B I}$$

where  $\Delta V_{34} = V_{34}(\text{for } +B) - V_{34}(\text{for } -B)$  and the Hall mobility can be calculated by

$$\mu_H = \frac{|R_H|}{\rho} .$$

## Double layer Hall Effect

Let us assume that we measure a sample that has two distinct layers. For such a simple two-layer structure with thickness  $t_1, t_2$  and conductivity  $\sigma_1, \sigma_2$  for Layer 1 and Layer 2, respectively, as shown in the figure below, the Hall coefficient is given by

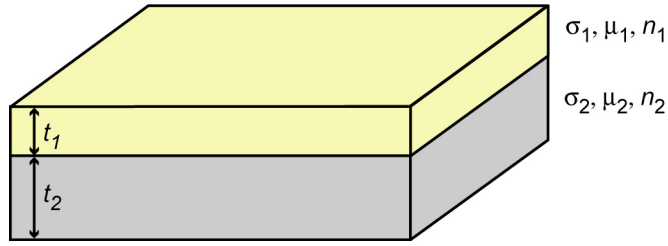
$$R_H = \frac{(t_1+t_2) \left[ (R_{H1} \sigma_1^2 t_1 + R_{H2} \sigma_2^2 t_2) + R_{H1} R_{H2} \sigma_1^2 \sigma_2^2 (R_{H1} t_2 + R_{H2} t_1) B^2 \right]}{(\sigma_1 t_1 + \sigma_2 t_2)^2 + \sigma_1^2 \sigma_2^2 (R_{H1} t_2 + R_{H2} t_1) B^2}$$

where  $R_{H1}$  and  $R_{H2}$  is the Hall coefficient for layer 1 and layer 2, respectively. In low magnetic field limit, it becomes

$$R_H = \frac{(t_1+t_2) (R_{H1} \sigma_1^2 t_1 + R_{H2} \sigma_2^2 t_2)}{(\sigma_1 t_1 + \sigma_2 t_2)^2} = R_{H1} \frac{t_1}{t_1+t_2} \left( \frac{\sigma_1}{\sigma} \right)^2 + R_{H2} \frac{t_2}{t_1+t_2} \left( \frac{\sigma_2}{\sigma} \right)^2$$

where

$$\sigma = \frac{t_1}{t_1+t_2} \sigma_1 + \frac{t_2}{t_1+t_2} \sigma_2 .$$



A detailed analysis shows that the *measured* carrier concentration is given by

$$n_H = \frac{n_1 n_2 \sigma^2 (t_1+t_2)}{n_2 t_1 \sigma_1^2 + n_1 t_2 \sigma_2^2} = \frac{(n_1 \mu_1 t_1 + n_2 \mu_2 t_2)^2}{(n_1 \mu_1^2 t_1 + n_2 \mu_2^2 t_2) (t_1+t_2)}$$

and the *measured* mobility is given by

$$\mu_H = \mu_1 \frac{t_1}{t_1+t_2} \frac{\sigma_1}{\sigma} + \mu_2 \frac{t_2}{t_1+t_2} \frac{\sigma_2}{\sigma} = \frac{n_1 \mu_1^2 t_1 + n_2 \mu_2^2 t_2}{n_1 \mu_1 t_1 + n_2 \mu_2 t_2} .$$